Application No.: 10/521,141 Docket No.: SONYJP 3.3-1079

## IN THE CLAIMS

## 1. (canceled)

2. (currently amended) The method for decorating the surface of a die according to claim—14, in which the wherein molding stepthe film like photomask into the same shape as that of said die is performed by includes heating the photomask and sticking a heated photomask to a predetermined die.

## (canceled)

4. (new) A method for decorating a surface of a die usable for forming a three-dimensional object by a molding process, said method comprising the steps of:

coating the surface of the die with a photoresist;

molding a photomask into a same shape as a shape of said die which corresponds to a shape of the three-dimensional object;

sticking the photomask molded into said shape to said die coated with the photoresist; and

causing a pattern formed on said photomask to be arranged onto said die,

in which the die is usable to form the three-dimensional object with the pattern formed thereon by the molding process.

- 5. (new) The method for decorating the surface of a die according to claim 4, in which the three-dimensional object is a diaphragm of a speaker.
- 6. (new) A method for forming a three-dimensional object, said method comprising the steps of:

forming a die, in which the forming step includes coating the surface of the die with a photoresist, molding a photomask into a same shape as a shape of said die which corresponds to a shape of the three-dimensional object, sticking the photomask molded into said shape to said die coated with the photoresist, and causing a pattern formed on said photomask to be arranged onto said die; and

using the formed die in a molding operation to form the three-dimensional object,

in which the formed three-dimensional object has the pattern thereon.

- (new) The method according to claim 6, in which the three-dimensional object is a diaphragm of a speaker.
- (new) A die usable in a molding process, in which the 8. die is formed by coating a surface of said die with a photoresist, sticking a photomask molded into a same shape as a shape of said die to the photoresist coated surface, and causing a pattern made on said photomask to be formed on the surface of said die, in which the die is usable to form a three-dimensional object having the pattern formed thereon by the molding process.